



FORM PTO-149 (Rev. 2-32)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. A34237	Serial No. 09/843,354
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		Applicant: Gye-Chool Lee	
		Filing Date: April 26, 2001	Group: 2662

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
hc	1. 5,483,527	1/9/1996	Doshi et al.	370	60.1	12/21/1994
hc	2. 5,483,537	1/9/1996	Dupy	370	95.3	3/2/1994
hc	3. 5,517,188	5/14/1996	Carroll et al.	340	825.54	2/24/1994

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc).

hc	4.	Office Action from Korean Patent Application No. KR2000-0022519, dated April 25, 2002, (with translation).
EXAMINER		DATE CONSIDERED <i>3/4/05</i>

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.



Form PTO-1249 U.S. Department of Commerce (REV. 2-82) Patent and Trademark Office								Atty. Docket No. 067515.0146 (A34237)	Serial No. 09/843,354	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)								Applicant Gye-Chool Lee		
								Filing Date April 26, 2001	Group 2662 2661 RECEIVED	
								JUL 17 2001		
								Technology Center 2600		

U.S. PATENT DOCUMENTS

Exam. Init.		Document No.							Date	Name	Class	Subclass	Filing Date if Approved
hc		5	4	8	3	5	2	7	01/09/96	Dupuy	370	-85-3	
hc		5	5	1	3	3	7	9	04/30/96	Benveniste et al.	455	33.1	
hc		5	7	8	7	3	4	4	07/28/98	Scheinert	455	422	
hc		6	1	0	4	9	3	0	08/15/00	Ward et al.	455	450	05/02/97

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation Yes No

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

Examiner	<i>Alongsolo</i>	Date Considered	<i>10/27/04</i>
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* Examiner: Initial citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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